

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: (Divisional of 09/853,090)

Filing Date: Herewith

Applicant: Yoshiaki EMOTO

Group Art Unit: 2827

Examiner: Luan C. Thai

Title: SEMICONDUCTOR DEVICE AND METHOD FOR
MANUFACTURING THE SAME

Attorney Docket: 9319S-208DVA

Director of the United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

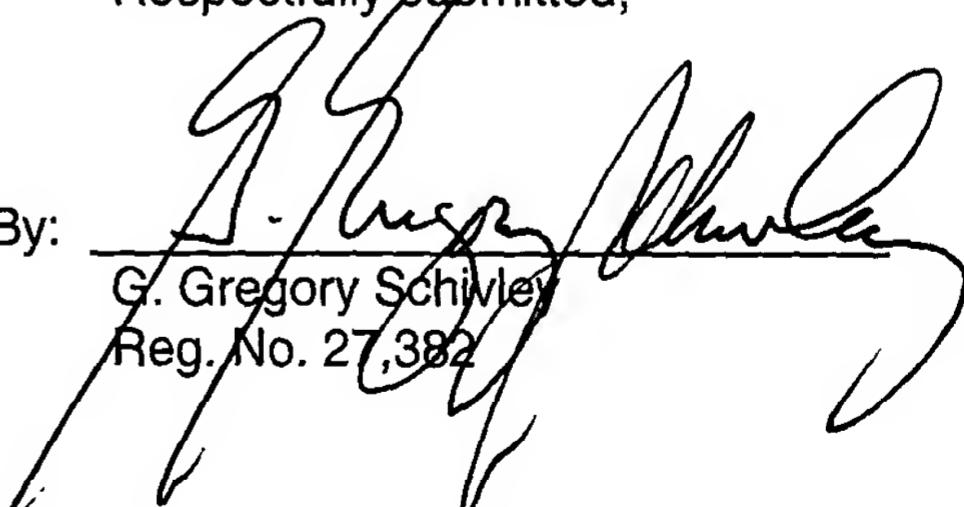
INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with the statutory provisions set forth in 37 CFR § 1.97 and 1.98, the Examiner is hereby respectfully advised of the references listed on the attached PTO-1449 Form. All of these references were made of record during prosecution of the parent application from which this divisional claims priority.

The listed references are cited only in the interest of candor and without any admission that they constitute statutory prior art, or contain matter which anticipates the invention or which would render the same obvious, either singly or in combination, to a person of ordinary skill in the art.

Respectfully submitted,

By: 

G. Gregory Schivley
Reg. No. 27,382

Dated: September 18, 2003

HARNESS, DICKY & PIERCE, P.L.C.
P.O. Box 828
Bloomfield Hills, Michigan 48303
(248) 641-1600

FORM HDP-1449 (Based on Form PTO-1449)		ATTORNEY DOCKET NO.	SERIAL NO.
		9319S-208DVA	
		APPLICANT	
		Yoshiaki EMOTO	
		FILING DATE	GROUP
		Herewith	2827

Sheet 1 of 1

U.S. PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.		6,147,401	Nov/2000	Solberg, Vernon		

FOREIGN PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation * Yes No
1.		11-135537	May/1999	Japan		
2.		10-005221	Jan/1998	Japan		
3.		09-331599	Dec/1997	Japan		

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)		
Ref. Desig.	Examiner's Initials	
1.		

* One or more of the English translation documents submitted herewith may be Abstracts only or partial machine created translations from the Japanese Patent Office. As such, the submitter does not necessarily vouch for their accuracy. Additional information may be obtained from the Japanese Patent Office web site at www.jpo.go.jp.

Examiner:	Date Considered:
-----------	------------------

EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.